



1763

SAM435-100/00645  
Customer No. 24,118

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: CHO, DONG-IL )  
SERIAL NO: 09/614,785 )  
FILED: 07/12/00 )  
FOR: SILICON ETCHING APPARATUS )  
USING XeF<sub>2</sub> )  
ART UNIT: 1763 )  
EXAMINER: HASSANZADEH )

#BA  
3/22/02  
MW

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MAR 20 2002

TC 1700

AMENDMENT

Director of United States Patent and Trademark Office  
Box Non-Fee Amendment  
Washington, D.C. 20231

Dear Sir:

In response to the Office Action dated December 10, 2001, the Applicant requests the above-identified application be re-examined in view of the following amendments and remarks:

**In the specification:**

Page 4, line 10, change "Figs. 2 and 3" to - -Figs 2a-2d and 3a-3d- -.

**In the claims:**

Please amend claims 1 and 3 as follows:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner of Patents, Washington, D.C. 20231, on March 5, 2002.

Amy Miles